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ABSTRACT OF THE DISCLOSURE

GaAs substrate (1), are formed a DBR (Distributed Bragg Reflector) (3), and a light-emitting layer (5) made of a plurality of layers of Al_vGa_zIn_{1-v-z}P $(0 \le y \le 1, 0 \le z \le 1)$ above the DBR (3). A semiconductor layer or a plurality of semiconductor layers (6) - (10) having a number of layers of 1 or more are formed on the lightemitting layer (5), and a grating pattern for scattering light is formed on a surface of the semiconductor layer (9) by photolithography and by etching with a sulfuric etchant. Thus, acid/hydrogen peroxide based semiconductor device small in radiation angle dependence of light emission wavelength, as well as a manufacturing method therefor, are provided.